Measuring DNA Translocation through Nanopores in Graphene and Carbon Nanomenbranes with Optical Tweezers

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Abstract:

We measured forces acting on DNA during translocation through a nanopore with Optical Tweezers. A video-based force detection and analysis system was developed, allowing for virtually interference-free axial force measurements with an overall force resolution of ±0.5pN at a sample rate of 123Hz [1].

We previously measured the translocation of dsDNA through 20nm thick Si_3N_4 membranes (0.1pN/mV for pores \geq 30nm) [2, 3]. Lipid coating as well as carbon nanomembranes and graphene with a thickness of 3nm and 0.3nm respectively allow for even more sensitive measurements.



• Video-based force detection \rightarrow reduced interference

Nanomembrane Preparation

Graphene



- Mechanical exfoliation with nitto tape
- Automated searching routine for graphene flakes based on colour in light microscope
- Transfer on chip with cellulose polymer

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Nanopore Preparation

- Calibration via Stokes friction and Allan variance
- Force sensitivity better than 0.5 pN at 123 Hz sample rate

Translocation Theory



- Dynamics dominated by electrohydrodynamic effects (electro-osmotic flow)
- Modelling with combination of Poisson, Nernst-Plack and Stokes equations
- Mere zero surface charge on coated membrane does not explain high forces

- Zeiss Orion Plus HIM
- 0.35 nm imaging resolution
- Pore sizes as small as 5-6 nm



Graphene

Carbon Nanomembranes



- ightarrow Introduction of slip length at the DNA-solution-interface
- Supported by theoretical treatment of DNA nanostructure [3] and recent MD simulations [4]

Results:

Slip length $l_{\rm slip} = 0.5$ nm

Surface charge for $Si_3N_4 \sigma_m = -60 \text{ mC/m}^2$

References

- [1] S. Knust *et al.*, Video-based and interference-free axial force detection and analysis for optical tweezers. Rev. Sci. Instr. **83**, 103704 (2012)
- [2] A. Spiering *et al.*, Nanopore translocation dynamics of a single DNA-bound protein. Nano Lett. **11**, 2978 (2011)
- [3] A. Sischka *et al.*, in preparation
- [4] S. Kesselheim, W. Müller, C. Holm, Origin of Current Blockades in Nanopore Translocation Experiments. Phys. Rev. Lett. **112**, 018101 (2014)



- Strongly localised heating phenomena (plasmon?)
- ightarrow Melts polystyrene beads
- → Dissipates biotin-streptavidin bond between bead and DNA

Distance between bead and membrane z [µm]

- 3 nm membrane thickness, 70 nm NP size, 50 mV, 20 mM KCl
- Interference caused by silicon chip geometry







PicoTweezers

Force Sensitive Optical Tweezers www.picotweezers.com



